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Attorney Docket: 061063-0311751

Client Reference: OSP-16220

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Confirmation Number:

SHIBAYAMA ET AL.

Group Art Unit:

Application No.:

Filed: September 3, 2004

Examiner:

Title: PROCESS FOR PRODUCING SILICON SINGLE CRYSTAL LAYER AND SILICON
SINGLE CRYSTAL LAYER

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Before beginning examination, please amend the above-identified National Stage
application as follows: